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APPLICANTS
Shyusei Ohya et al.

LIST OF PUBLICATIONS CITED BY APPLICANT

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FILING DATE 9/28/05 GROUP 1793

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/LH/	AA	US 2002/0146615 A1	10/10/02	Kiyoshi Yamaura et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
/LH/	AL	JP 62-163261 A	07/20/87	Japan			Abstract only	
/LH/	AM	EP 1 244 165 A2	09/25/02	Europe			x	
/LH/	AN	WO 03/092093 A2	11/06/03	PCT			x	
/LH/	AO	JP 2003-317728 A	11/07/03	Japan			Abstract only	
	AP							

OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

/LH/	AR	E.G. Chen et al., A STEM STUDY OF A PLATINUM DEPOSIT ON AN AMORPHOUS CARBON FILM: THE EFFECTS OF CONTACT VOLTAGE IN THE NUCLEATION PROCESS, Surface Science, Elsevier Science Publishers B.V. (North-Holland Physics Publishing Division), Vol. 144, 1984, Amsterdam, The Netherlands, pp. 465 - 476
/LH/	AS	BingShe Xu et al., FORMATION OF A NEW ELECTRIC MATERIAL: FULLERENE/METAL POLYCRYSTALLINE FILM, Materials Research Society Symposium Proceedings, Materials Research Society, Vol. 472, 1997, Pittsburgh, Pa., U.S., pp. 179 - 184
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EXAMINER /Patricia Hailey/

DATE CONSIDERED 01/08/2008

*EXAMINER: Initial if publication considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.